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PATENT  
29925/37976

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of: Dong-Su Park and  
Kwang-Seok Jeon

Serial No.: 10/021,322 ✓


Filed: December 12, 2001

For: Method for Manufacturing  
Tantalum Oxy Nitride Capacitors

Group Art Unit: 3729

Examiner: Donghai D. Nguyen

) I hereby certify that this paper and the  
) documents referred to as enclosed  
) therewith are being deposited with the  
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) Alexandria, Virginia 22313-1450

  
\_\_\_\_\_  
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## AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

Please enter the following amendment in the above-referenced patent  
application in response to the office action mailed on September 3, 2003.